Notice of References Cited Application/Control No. 10/620,499 Applicant(s)/Patent Under Reexamination NAKAMURA ET AL. Examiner Qi Han Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2002/0178004 A1	11-2002	Chang et al.	704/246
*	В	US-7,127,398 B1	10-2006	Yamagishi et al.	704/270
*	С	US-5,963,903 A	10-1999	Hon et al.	704/254
*	D	US-2001/0041977	11-2001	Aoyagi et al.	704/246
	Ε	US-			
	F	US-			·
	G	US-			
	Н	US-		·	
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
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	s					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	x	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.